



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroshi KAMAKURA et al.

Group Art Unit: 2141

Application No.: 09/743,112

Examiner: A. Baugh

Filed: January 16, 2001

Docket No.: 108100

For: MEETING SYSTEM AND INFORMATION STORAGE MEDIUM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

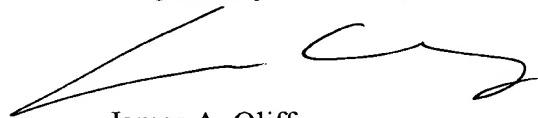
Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection, Notice of Allowance or other action that closes prosecution (e.g., Quayle Action).
- a. I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(1).
- 2. The references 1-8 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- 3. An English language Abstract of the non-English language reference 4 is attached hereto.

4. A computer-generated English language translation of the following Japanese reference has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See Reference 4.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

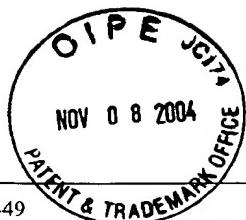
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Date: November 8, 2004

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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 108100	APPLICATION NO. 09/743,112	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Hiroshi KAMAKURA et al.		
				FILING DATE January 16, 2001	GROUP 2141	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	1	EP 0 847 178 A2	06/10/1998	Europe		
	2	GB 2 324 175 A	10/14/1998	Great Britain		
	3	WO 99/06910	02/11/1999	WIPO		
	4	JP A 6-4498 w/Abstract and Translation	01/14/1994	Japan		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
	5	Bodendorf et al., "Telelearning in the virtual lecture theatre," Displays, Elsevier Science Publishers BV., vol. 17, no. 3-4, May 1, 1997, pages 147-151				
	6	Franze et al., "An Infrastructure for Collaborative Teleteaching," Enabling Technologies: Infrastructure for Collaborative Enterprises, 1997, Proceedings., Sixth IEEE Workshops on Cambridge, MA, USA 18-20, June 18, 1997, pages 341-346				
	7	Sun Microsystems: "Jini™ Technology and Emerging Network Technologies," Sun Microsystems, January 18, 1999, the whole document				
	8	"Sun Microsystems Jini™ Architectural Overview," Sun Microsystems ICG White Paper, XX, XX, January 1999, pages 1-27				
EXAMINER				DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						